

**PATENT APPLICATION
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q79867

Nobuyuki ETO, et al.

Appln. No.: 10/777,680

Group Art Unit: 1791

Confirmation No.: 5870

Examiner: Jason L. LAZORCIK

Filed: February 13, 2004

For: METHOD OF PROCESSING A GLASS SUBSTRATE FOR A MAGNETIC DISK AND
METHOD OF MANUFACTURING THE GLASS SUBSTRATE

PETITION FOR EXTENSION OF TIME UNDER 37 C.F.R. § 1.136

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 C.F.R. § 1.136, Applicant hereby petitions for an extension of time of two month(s), extending the time for responding to the Office Action of August 21, 2008 to January 21, 2009.

The statutory fee of \$490.00 is being charged to Deposit Account No. 19-4880 via EFS Payment Screen. The USPTO is directed and authorized any other required fees, except for the Issue Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any overpayments to said Deposit Account.

Respectfully submitted,

/Alan J. Kasper/

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Date: January 15, 2009